

PVIA-4TE-10.6-1x1-TO8-wZnSeAR-36

**PRELIMINARY
DATASHEET**

**InAs/InAsSb superlattice
four-stage TE cooled
optically immersed
photovoltaic infrared detector**



FEATURES

Spectral range: 2.2 to 11.3 μm
III-V material compliant with the RoHS Directive
Unique optical immersion technology applied
Back-side illuminated
Long term stability
Fast response
No minimum order quantity required

APPLICATIONS

CO_2 laser (10.6 μm) measurements
Laser power monitoring and control
Laser beam profiling and positioning
Laser calibration
Semiconductor manufacturing
Glucose monitoring
Detection of hazardous chemicals in the air

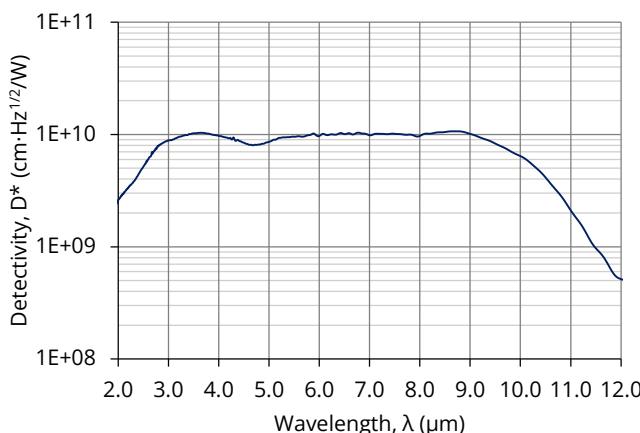
DETECTOR CONFIGURATION

| Detector symbol | PVIA-4TE-10.6-1x1-TO8-wZnSeAR-36 |
|--------------------------|--|
| Detector type | photovoltaic |
| Active element material | epitaxial InAs/InAsSb superlattice |
| Optical area, A_o | heterostructure 1 mm \times 1 mm |
| Immersion | hyperhemisphere |
| Cooling | 4TE |
| Temperature sensor | thermistor |
| Detector package | TO8 |
| Acceptance angle, Φ | \sim 36 deg. |
| Window | wZnSeAR (3 deg. wedged zinc selenide, anti-reflection coating) |

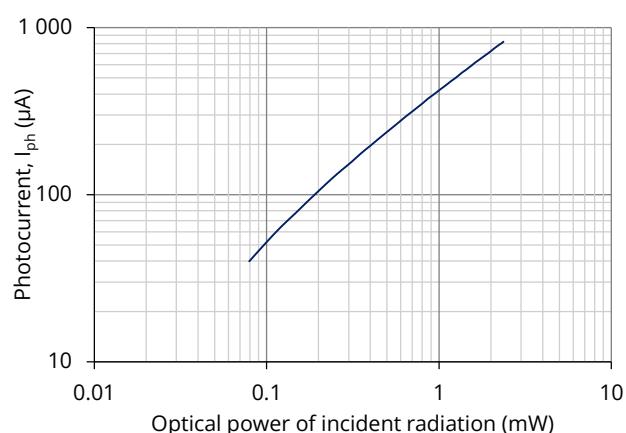
SPECIFICATION ($T_{\text{amb}} = 293 \text{ K}$, $T_{\text{chip}} = 200 \text{ K}$, $V_b = 0 \text{ V}$, unless otherwise noted)

| Parameter | Test conditions/remarks | Value | | | Unit |
|--|---|-------------------|----------------------|------|--|
| | | Min. | Typ. | Max. | |
| Active element temperature, T_{chip} | | - | 200 | - | K |
| Cut-on wavelength, $\lambda_{\text{cut-on}}(10\%)$ | At 10% of peak responsivity | - | 1.8 | 2.1 | μm |
| Peak wavelength, λ_{peak} | | - | 6.7 | - | μm |
| Cut-off wavelength, $\lambda_{\text{cut-off}}(10\%)$ | At 10% of peak responsivity | 10.8 | 11.3 | - | μm |
| Detectivity, D^* | At λ_{peak} , $f = 20 \text{ kHz}$ | 8.0×10^9 | 1.0×10^{10} | - | $\text{cm} \cdot \text{Hz}^{1/2}/\text{W}$ |
| Current responsivity, R_i | At λ_{peak} | 0.45 | 0.55 | - | A/W |
| Time constant, τ | | - | 3 | 5 | ns |
| Resistance, R | | 350 | 500 | - | Ω |

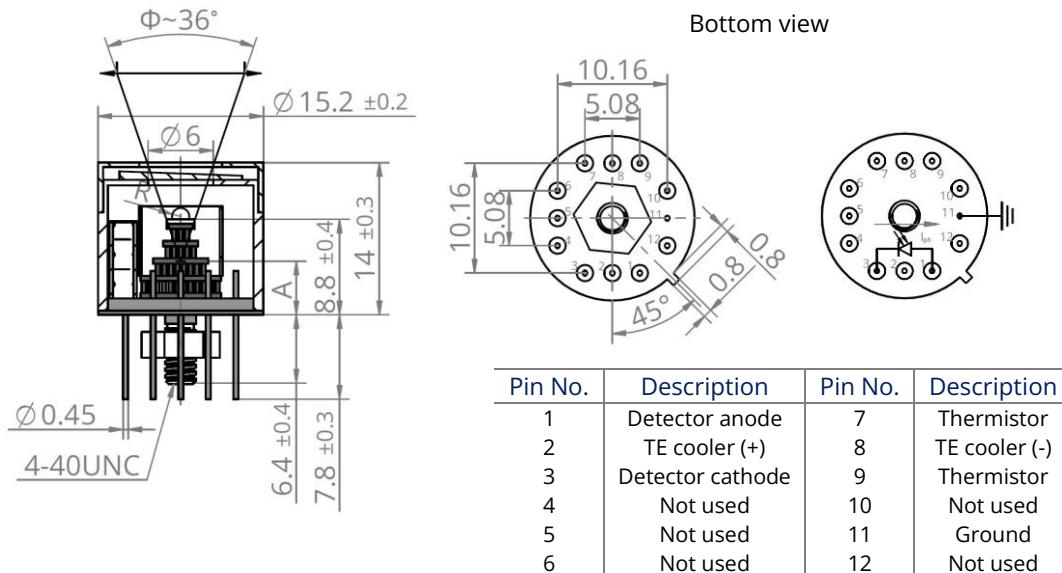
SPECTRAL RESPONSE (Typ., $T_{\text{chip}} = 200 \text{ K}$)



LINEARITY (Typ., $T_{\text{chip}} = 293 \text{ K}$, $\lambda = 4.55 \mu\text{m}$)



MECHANICAL LAYOUT AND PINOUT (Unit: mm)



Φ – acceptance angle

R = 0.8 mm (hyperhemisphere microlens radius)

A – distance from the bottom of the TO8 header to the focal plane

ABSOLUTE MAXIMUM RATINGS

| Parameter | Test conditions/remarks | Value | Unit |
|---|--|------------|---|
| Maximum incident optical power density | Continuous wave (CW) or single pulses $\geq 1 \mu\text{s}$ duration Single pulses $< 1 \mu\text{s}$ duration | 2.5 10 | W/cm^2 kW/cm^2 |
| Maximum bias voltage, $V_{\text{b max}}$ | | -1.0 | V |
| Soldering temperature | Within 5 s or less | ≤ 370 | $^\circ\text{C}$ |
| Ambient operating temperature, T_{amb} | Operation at $T_{\text{amb}} > 30^\circ\text{C}$ may increase the active element temperature and reduce the performance of the detector below specified parameters | -40 to 85 | $^\circ\text{C}$ |
| Storage temperature, T_{stg} | | -40 to 85 | $^\circ\text{C}$ |
| Storage humidity | No dew condensation | 10 to 90 | % |
| Maximum TE cooler current, $I_{\text{TEC max}}$ | | 0.4 | A |
| Maximum TE cooler voltage, $V_{\text{TEC max}}$ | | 8.3 | V |

Stresses beyond those listed under Absolute Maximum Ratings may cause permanent damage to the device.

Constant or repeated exposure to absolute maximum rating conditions may affect the quality and reliability of the device.